

Patents:

1. Xiaodong Wang and P.K.Ajmera, "Laterally movable gate field effect transistors for microsensors and microactuators," US Patent # 6,204,544, granted March 20, 2001.

Technology Disclosures:

1. P. K. Ajmera and Frank Greenway, "A remotely controlled gastric pacemaker for the treatment of obesity," Technology Disclosure, Filed Oct. 26, 1999, Office of Intellectual Property, LSU. OIP No: 9932 (Pennington No: 0-99-01).
2. M. Feldman, P. Ajmera and A. Srivastava, "Light Valve Array," Technology Disclosure, Filed Feb. 20, 2004, Office of Intellectual Property, LSU. OIP No: 0407.
3. Naga S. Korivi and Pratul K. Ajmera, "Microfabrication on cylindrical, oval and other non-planar surfaces," Filed Dec. 21, 2007, LSU, Office of Intellectual property, OIP No: 0822.
4. J. Camacho, P. K. Ajmera, E. Sajo and W. Wang, "Hybrid conversion isotopic electrical power source," Filed Feb. 28, 2008, LSU Office of Intellectual Property, OIP No: 0832.
5. Naga Srinivas Korivi and Pratul K. Ajmera, "Subcutaneous interface for implant-to-external world interconnections," Filed June 26, 2008, LSU Office of Intellectual Property, OIP No: 0846.
6. Naga Srinivas Korivi and Pratul K. Ajmera, "Implantable clip-on micro-cuff electrode for functional electrical stimulation and bio-potential recording," Filed June 26, 2008, LSU Office of Intellectual Property, OIP No: 0845, Patent filed 12/15/2009, (Attorney: Jason Mueller), United States Patent Application: US 12/653,476. Publication No: 2010/0168831 A1, July 1, 2010 [<http://www.faqs.org/patents/app/20100168831>].
7. Naga Srinivas Korivi and Pratul K. Ajmera, "Method for Incorporating Selective and At-large Porosity in Elastomeric Layers and Microfluidic Structures," LSU OIP # 210-11, submitted 12/2/2009 (Attorney – John Runnels), Provisional Application Filed 12/4/2009, File No. Korivi 1012 B, Serial No: 61/266,765.
8. Naga S. Korivi and Pratul K. Ajmera, "Bio-implantable Pacing Electrode with Thermally Regulated Structural Flexibility," LSU OIP #1030, submitted 3/30/2010.
9. Naga S. Korivi and Pratul K. Ajmera, "Method of Incorporating Porosity on Silicon Surface." LSU OIP #1036, submitted 5/3/2010.